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Brian D. Ogonowsky  
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May 16, 2003

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Re: Applicant(s): Kirk Martin  
Assignee: Nisene Technology Group  
Title: Method and Apparatus for Etching a Semiconductor Die  
Serial No.: 09/902,931  
Examiner: Vinh, Lan  
Docket No.: M-11706 US (NTG-P101)  
Filed: July 10, 2001  
Group Art Unit: 1765

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (1 page in duplicate);
- (3) Response to Office Action (15 pages).

- ☐ No additional fee is required.  
☒ The fee has been calculated as shown below:

	Claims Remaining After Amendment		Highest No. Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	35	Minus	34	=	1	x \$9	\$ 9.00
Independent Claims	6	Minus	5	=	1	x \$42	\$ 42.00
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application						\$
<input checked="" type="checkbox"/>	Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.						
<input checked="" type="checkbox"/>	Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 502226.						
Total:						\$	51.00

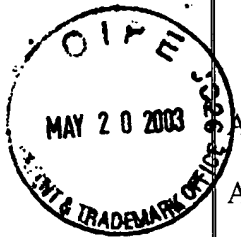
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Alexandria, VA 22313-1450, on May 16, 2003.

Carmen C. Cook  
Attorney for Applicant(s)

5/16/2003  
Date of Signature

Respectfully submitted,

Carmen C. Cook  
Carmen C. Cook  
Attorney for Applicant(s)  
Reg. No. 42,433



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#9/A  
5/22/03  
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San Jose, California  
May 16, 2003

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed February 19, 2003, Applicant submits the following amendments and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks begin on page 11 of this paper.

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01 FC:2201 42.00 CH  
02 FC:2202 9.00 CH

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